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(Modified)U.S. Department of Commerce  
Patent and Trademark OfficeAttorney's Docket No.  
05770-156002Application No.  
10/673,307**Information Disclosure Statement  
by Applicant**

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(Use several sheets if necessary)

Applicant  
Martin W. Rupich et al.Filing Date  
September 29, 2003Group Art Unit  
1762**U.S. Patent Documents**

Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

**Foreign Patent Documents or Published Foreign Patent Applications**

Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
	AL	WO 94/17078	08/04/1994	WIPO				
	AM	EP 0 277 020 A1	08/03/1988	Europe				
	AN							
	AO							

**Other Documents (include Author, Title, Date, and Place of Publication)**

Examiner Initial	Desig. ID	Document
	AP	Peizhi, Preparation of $\text{YBa}_2\text{Cu}_3\text{O}_{7-x}$ Superconducting Thin Films by Metalorganic Deposition, Rare Metal Materials and Engineering, Vol. 24, No. 6, pp58-63, 1995.
	AQ	
	AR	
	AS	

Examiner Signature

Date Considered

EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.